In the United States Patent and Trademark Office

Appn. Numbe	r						
Appn. Filed:						_	
Applicant(s):_	JOI	IS ET AL.	•				
Appn. Title:_	ROTATING	OR ROTAT	TABLE COM	PENSATOR	SPECTE	ROSCOPIC	ELLIPSOMETER
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Information Disclosure Statement

Commissioner of Patents and Trademarks Washington, District of Columbia 20231

Sir:

Attached is a completed Form PTO-1449 and copies of the pertinent parts of the references cited thereon. Following are comments on these references pursuant to Rule 98:

THE IDENTIFIED PATENTS AND ARTICLES ARE NOT ACCOMPANYING AS THEY WERE PREVIOUSLY SUBMITTED IN CO-PENDING APPLICATIONS AND ARE AVAILABLE IN THE FILES OF SAID APPLICATIONS:

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Co-Pending Application Serial No. 09/583,229 Filed 05/30/2000; Co-Pending Application Serial No. 09/945,962 Filed 09/04/2001; Co-Pending Application Serial No. 10/034,800 Filed 12/28/2001; Co-Pending Application Serial No. 10/699,540 Filed 11/01/2003;
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IDENTIFIED PATENTS

Patents of which the Inventor is aware include those to:

Woollam et al, No. 5,373,359, Johs et al. No. 5,666,201 Green et al., No. 5,521,706, Johs et al., No. 5,504,582

and are disclosed for general information as they pertain to ellipsometer systems.

Further Patents of which the Inventor is aware include:

Nos. 5,757,494 and 5,956,145 to Green et al., in which are taught a method for extending the range of Rotating Analyzer/Polarizer ellipsometer systems to allow measurement of DELTA'S near zero (0.0) and one-hundred-eighty (180) degrees, and the extension of modulator element ellipsometers to PSI'S of forty-five (45) degrees. Said Patents describes the presence of a variable, transmissive, bi-refringent component which is added, and the

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application thereof during data acquisition to enable the identified capability.

Patent No. 5,706,212 to Thompson et al. is also disclosed as it teaches a mathematical regression based double Fourier series ellipsometer calibration procedure for application, primarily, in calibrating ellipsometers system utilized in infrared wavelength range. Bi-refringent, transmissive window-like compensators are described as present in the system thereof, and discussion of correlation of retardations entered by sequentially adjacent elements which do not rotate with respect to one another during data acquisition is described therein.

Patent to He et al., No. 5,963,327 is disclosed as it describes an ellipsometer system which enables providing a polarized beam of electromagnetic radiation at an oblique angle-of-incidence to a sample system in a small spot area.

Patent to Johs et al., No. 5,872,630 is disclosed as it describes an ellipsometer system in which an analyzer and polarizer are maintained in a fixed in position during data acquisition, while a compensator is caused to continuously rotate.

Patent to Dill et al., No. 4,953,232 is disclosed as it describes a rotating compensator ellipsometer system.

Patents disclosed as they Claim various Compensator Designs are:

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No. 5,946,098 to Johs et al.;
No. 5,963,325 to Johs et al.;
No. 6,084,674 to Johs et al.;
No. 6,084,675 to Herzinger et al.;
No. 6,100,981 to Johs et al.;
No. 6,118,537 to Johs et al.;
No. 6,141,102 to Johs et al.
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Patent 4,556,292 to Mathyssek et al. and

Patent No. 5,475,525 to Tournois et al.;

are disclosed as they were cited in examination of some of the just disclosed Patents.

Patent to Coates et al., No. 4,826,321 is disclosed as it describes applying a reflected monochromatic beam of plane polarized electromagnetic radiation at a Brewster angle of incidence to a sample substrate to determine the thickness of a thin film thereupon. This Patent also describes calibration utilizing two sample substrates, which have different depths of surface coating.

Other Patents which describe use of reflected electromagnetic

radiation to investigate sample systems are:

RE 34,783, 4,373,817, and 5,045,704 to Coates.

Patent to Bjork et al., No. 4,647,207 is disclosed as it describes an ellipsometer system which has provision for sequentially positioning a plurality of reflective polarization state modifiers in a beam of electromagnetic radiation. While said 207 Patent mentions investigating a sample system in a transmission mode, no mention or suggestion is found for utilizing a plurality of transmitting polarization state modifiers. Patent Nos.:

4,210,401; 4,332,476; and 4,355,903;

are also identified as being cited in the 207 Patent. It is noted that systems as disclosed in these Patents, (particularly in the 476 Patent), which utilize reflection form an element to modify a polarization state can, if such an element is an essential duplicate of an investigated sample and is rotated ninety degrees therefrom, the effect of the polarization state modifying element on the electromagnetic beam effect is extinguished by the sample.

Patent to Mansuripur et al., No. 4,838,695 is disclosed as it describes an apparatus for measuring reflectivity.

Patents to Rosencwaig et al., Nos.:

4,750,822; and 5,595,406

are also identified as they describe systems which impinge electromagnetic beams onto sample systems at oblique angles of incidence. The 406 Patent provides for use of multiple wavelengths and multiple angles of incidence. For similar reasons Patent No.:

5,042,951

to Gold et al. is also disclosed.

Patent to Osterberg, No. 2,700,918 describes a microscope with variable means for increasing the visibility of optical images, partially comprised of discrete bi-refringent plates which can be positioned in the pathway between an eyepiece and an observed object. Other Patents identified in a Search which identified said 918 Patent are Nos.:

3,183,763 to Koester; 4,105,338 to Kuroha; 3,992,104 to Watanabe;

and a Russian Patent, No. SU 1518728. Said other Patents are not believed to be particularly relevant, however.

Patent No. 5,329,357 to Bernoux et al. is also identified as it Claims use of fiber optics to carry electromagnetic radiation to and from an ellipsometer system which has at least one polarizer or analyzer which rotates during data acquisition. It is noted that if both the polarizer and analyzer are stationary during data acquisition that this Patent is not controlling where electromagnetic radiation carrying fiber optics are present.

Patent No. 6,628,917 to Johs is disclosed as present invention preferred practice is to utilize a spectroscopic source of electromagnetic radiation with a relatively flat spectrum over a large range of wavelengths.

Patent to Chen et al., No. 5,581,350, is disclosed as it describes a method for regression calibration of ellipsometers.

Patent No. 6,608,526 to Piwonka-Corle et al is disclosed, as is

Patent No. 5,596,411 to Fanton et al.,

as the Applicant is aware thereof.

Patents which focus on the use of Lenses in Ellipsometer Systesm are:

Patent Nos. 5,877,859 and 5,798,837 to Aspnes et al.;

Patent No. 5,333,052 to Finarov;

Patent No. 5,608,526 to Piwonka-Corle et al.;

Patent No. 5,793,480 to Lacy et al.;

Patent Nos. 4,636,075 and 4,893,932 to Knollenberg; and

Patent No. 4,668,860 to Anthon.

Patent found is No. 5,917,594 to Norton is the most relevant the system disclosed therein utilizes a spherical mirror to focus an electromagentic beam onto the surface of a sample in the form of a small spot.

IDENTIFIED SCIENTIFIC PAPERS

A paper by Johs, titled "Regression Calibration Method for Rotating Element Ellipsometers", Thin Solid Films, 234 (1993) is also disclosed as it describes a mathematical regression based approach to calibrating ellipsometer systems.

Another paper, by Gottesfeld et al., titled "Combined

Ellipsometer and Reflectometer Measurements of Surface Processes on Nobel Metals Electrodes", Surface Sci., 56 (1976), is also identified as describing the benefits of combining ellipsometry and reflectometry.

A paper by Smith, titled "An Automated Scanning Ellipsometer", Surface Science, Vol. 56, No. 1. (1976), is also mentioned as it describes an ellipsometer system which does not require any moving, (eg. rotating), elements during data acquisition.

Additional papers, by Azzam and Azzam et al. are also identified as concerning alternative approaches to the goal of the present invention, and are titled:

"Multichannel Polarization State Detectors For Time-Resolved Ellipsometry", Thin Solid Film, 234 (1993); and

"Spectrophotopolarimeter Based On Multiple Reflections In A Coated Dielectric Slab", Thin Solid Films 313 (1998); and

And two more papers by Azzam et al. are also disclosed:

"General Analysis And Optimization Of The Four-Detector Photopolarimeter", J. Opt. Soc. Am., A, Vol. 5, No. 5 (May 1988); and

"Accurate Calibration Of Four-Detector Photopolarimeter With Imperfect Polarization Optical Elements", J. Opt. Soc. Am., Vol. 6, No. 10, (Oct. 1989);

A review paper by Collins, titled "Automatic Rotating Element Ellipsometers: Calibration, Operation and Real-Time Applications", Rev. Sci. Instrum., 61(8) (1990), is identified for general information.

JAMES D. WELCH REG. NO. 31,216

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PLEASE USE THE FOLLOWING FOR PTO FORM 1449 FOR ARTICLES

Paper by Johs, titled "Regression Calibration Method for Rotating Element Ellipsometers", Thin Solid Films, 234 (1993).

Paper, by Gottesfeld et al., titled "Combined Ellipsometer and Reflectometer Measurements of Surface Processes on Nobel Metals Electrodes", Surface Sci., 56 (1976).

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